



Study of latent defects related to SEL induced by laser pulses on COTS and their impact on long-term reliability

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TRAD

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■ Context

- Study funded by CNES – device reliability team (contact : Gianandrea QUADRI)
- “New Space” trend → increasing use of COTS
- Many CMOS-based COTS are sensitive to SEL
 - New-Space → more flexible requirements in terms of reliability
 - Implementing a delatching system
- Still possible to add a SEL-protection system, but ...
 - Latent damages induced by SEL electrical stress ?
 - Impact on “reliability” ?

■ Objectives of this preliminary study

- Build and validate a method to evaluate the impact of SEL on reliability based on literature
- Tests using pulsed Laser
 - Cost-efficient
 - Spatial and temporal resolution (focused area, control of SEL triggering, reproducibility)
 - Complementary to heavy ion testing
 - But need to validate the method by comparison with heavy ion testing

Bibliography

[Davydov,2017] G. G. Davydov *et al.*, « Approach to estimation of modern IC's sustainability after series of single events », RADECS 2017 IEEE Proceedings
[Tsirkov,2018] A. N. Tsirkov *et al.*, « Latent SEL-induced damage in CMOS ICs », RADECS 2018 IEEE Proceedings
[Skorobogatov,2017] P. K. Skorobogatov « Behavior of modern integrated circuit after latch-up parrying », RAD Conference, 2017

■ Content of this preliminary study

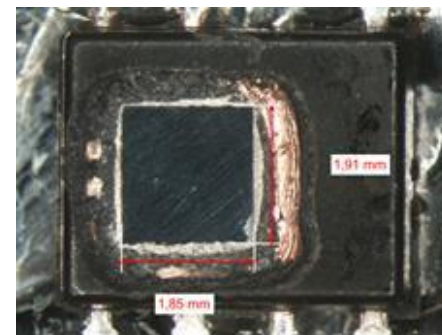
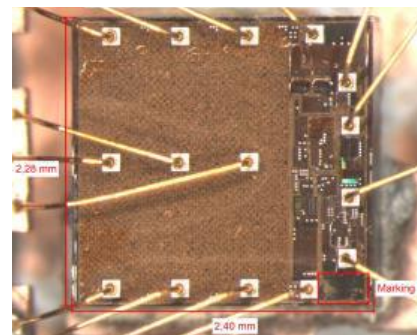
- ✦ Selection of COTS sensitive to SEL with available heavy ion data
- ✦ SEL triggering using pulsed Laser
 - Device delidding and test bench development
 - Validation of Laser test representativity by comparison with heavy ion tests
 - Identification of sensitive area locations
 - Triggering of a defined number of SEL in these sensitive areas
- ✦ Impact of SEL on reliability
 - Life Test on one COTS reference over
 - 5 backside delidded devices
 - 1 backside delidded device (non irradiated)
 - 1 non-delidded devices used as reference
 - Life Test 1000h at 125°C
 - Electrical parameters verified after the test
 - Consumption current I_{CC}
 - Other interesting parameters

Devices under study

■ Selection of 2 COTS references

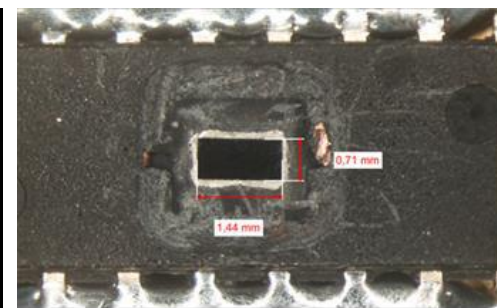
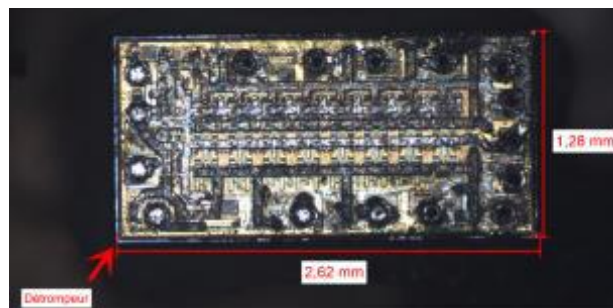
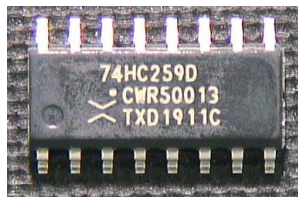
- ✦ TF6002 : DC-DC converter

Device	Manufacturer	Function	Input Voltage	Output current
TF6002	Telefunken	2A, 26V, Synchronous Rectified Step-Down Converter	-0.5 to 7 V	± 25 mA

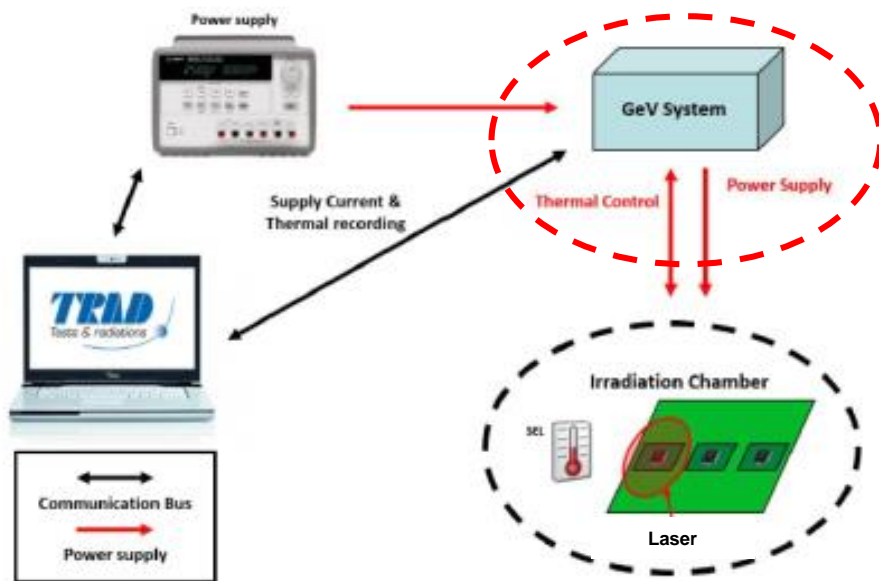


- ✦ 74HC259D : 8 bits adressable latch (buffer)

Device	Manufacturer	Function	Input Voltage	Output Voltage
74HC259D	Nexperia	8-bit addressable latch	4.5V to 26V	0.923V to 23V

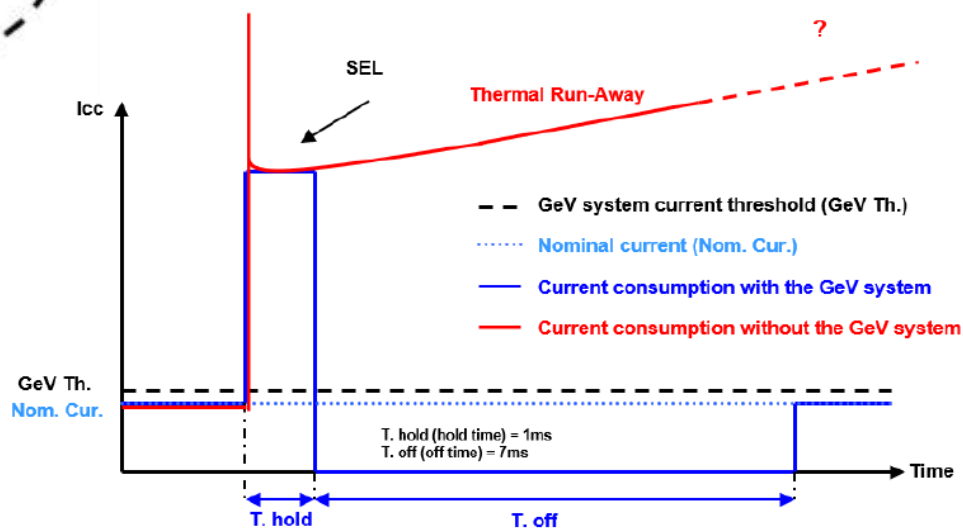


Test Bench – General Overview



GeV delatching system parametrization

- SEL detection threshold
- Hold time
- Off time



■ TF6002 DC-DC converter

- ▶ Laser test only

Supply voltage	Nominal supply current	Temperature
$V_{IN} = 4.5V$ to 26V	22 mA to 53 mA	25°C and 85°C

■ 74HC259D 8 bits adressable latch (buffer)

- ▶ Laser test
- ▶ Life Test

Supply voltage	Nominal supply current	Temperature
$V_{IN} = 4.5V$ to 26V	22 mA à 53 mA	25°C and 85°C

Test board

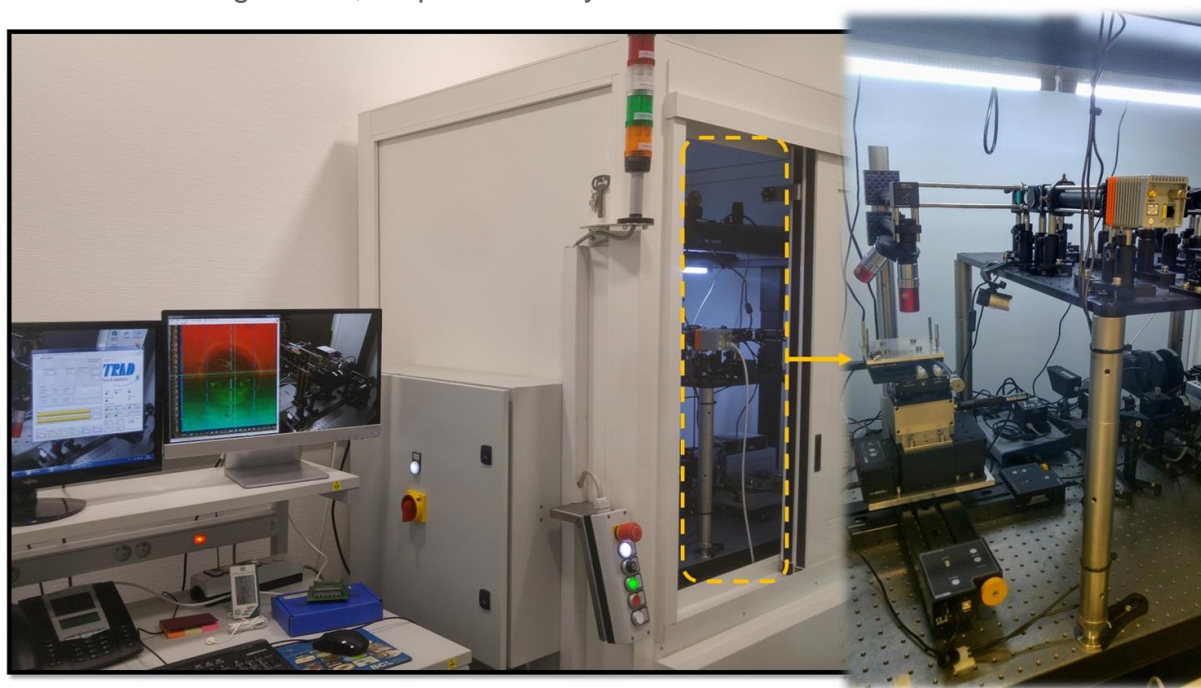
- Clock CLK generated by a LTC6900
- 74HC259D test conditions:
 - CLK in D input
 - Q_0 output = D
 - Q_7 output = low level

Life Test conditions

- I_{CC}
- V_{OL} et V_{OH} : low and high clock level in Q_0 output
- Q_7 : validation of low level

■ Pulsed laser tests at LISA NG facility

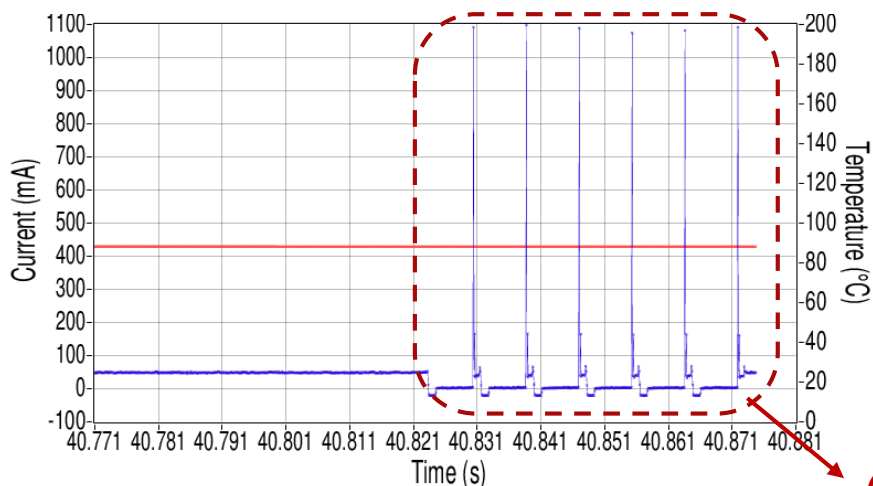
- Facility available at TRAD in Labège – *Laser Irradiation system for SEE Analysis*
- Pulsed Laser parameters
 - Wavelength $\lambda = 1064\text{nm}$
 - Pulse duration $\tau = 400\text{ ps}$
 - Pulse energy : ajustable from 0,1 nJ à $> 100\text{nJ}$
 - Focusing : plan apochromat Objectives, spot diameter $2.6\mu\text{m}$ @ $1/e^2$
 - Motorized linear stages XYZ, $0.1\mu\text{m}$ accuracy



- Tests performed on backside-delidded components

■ Preliminary pulsed laser test → Laser vs Heavy Ion validation

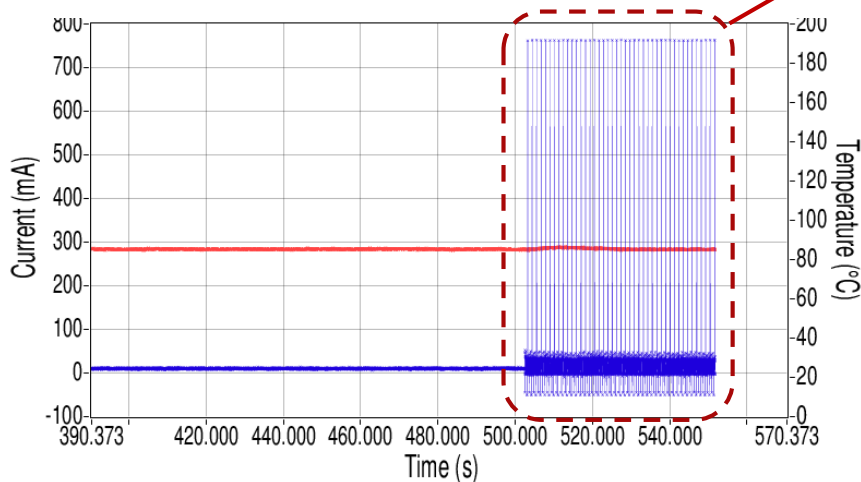
► TF6002



Laser test

Pulse energy = 14nJ
 $V_{CC} = 18V$
 $T = 85^{\circ}C$

**SEL Loop
(device out
of order)**



Heavy ions

LET = 45.8 MeV.cm².mg⁻¹
 $V_{CC} = 18V$
 $T = 85^{\circ}C$

Observations

- Destructive SEL triggered either by laser pulses and heavy ions
- Same SEL current signature
- Many attempts to generate non-destructive SEL with laser (reduction of V_{CC} and of pulse energy)
→ systematic destruction, as it was during heavy ion tests

Conclusion → Good representativity of Laser

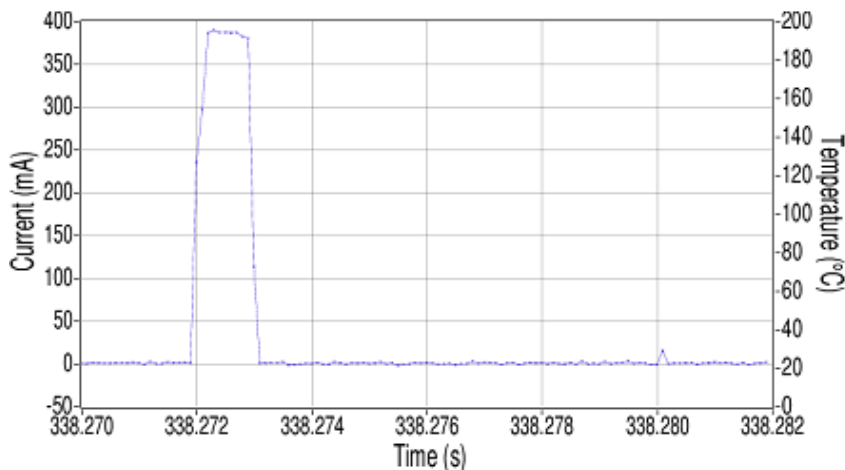
GeV delatching system parametrization

SEL detection threshold current	Hold time	Off time
35 mA to 75 mA	200 ms to 500 ms	7 ms

■ Preliminary pulsed laser test → Laser vs Heavy Ion validation

➤ 74HC259D

- Events triggered in sensitive regions



Laser test

Pulse energy = 2.1 nJ

$V_{CC} = 5V$

$T = 125^{\circ}C$

SEL detection parameters

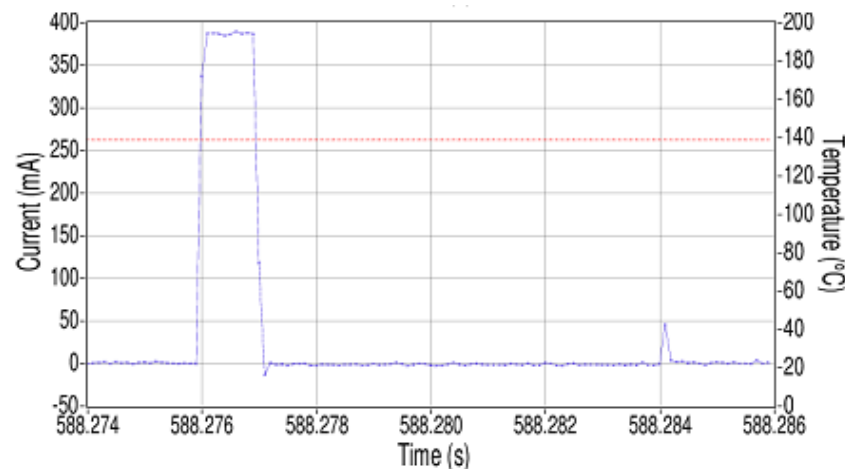
Threshold current = 30 mA

Hold time = 1 ms

Observations

- Same current signature

Conclusion → Good representativity of Laser



Heavy ions

LET = 46.1 MeV.cm².mg⁻¹

$V_{CC} = 5V$

$T = 125^{\circ}C$

SEL detection

Threshold current = 10 mA

Hold time = 1 ms

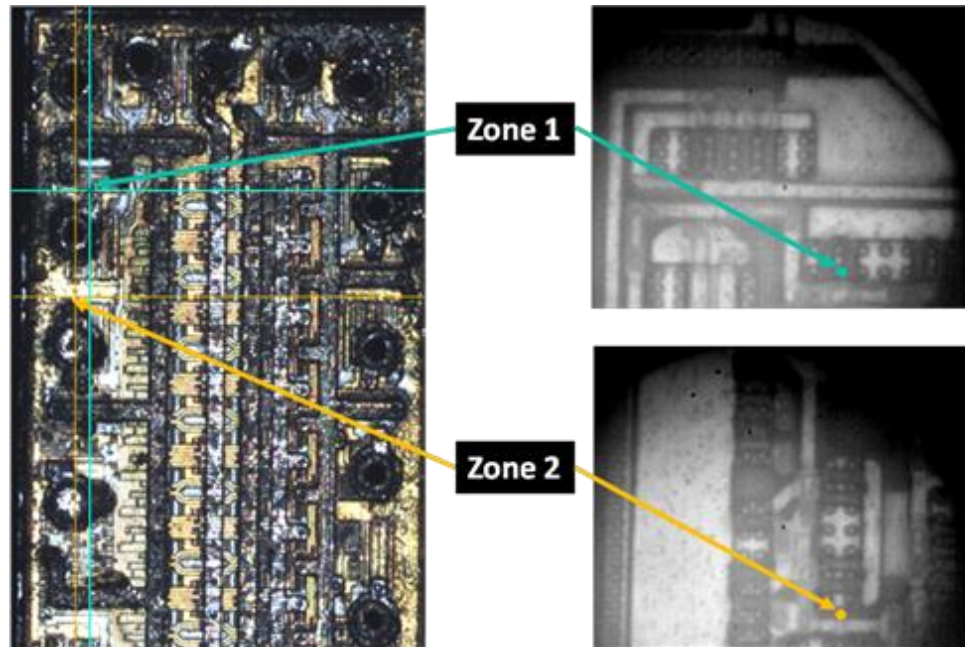
■ Laser tests → location of SEL sensitive areas on 74HC259D

✦ Location of sensitive areas

- Pulse energy = a few nJ
- Accurate mapping with Laser to localize sensitive areas
- Focus on these areas for the purpose of the study

→ Identification of two sensitive areas

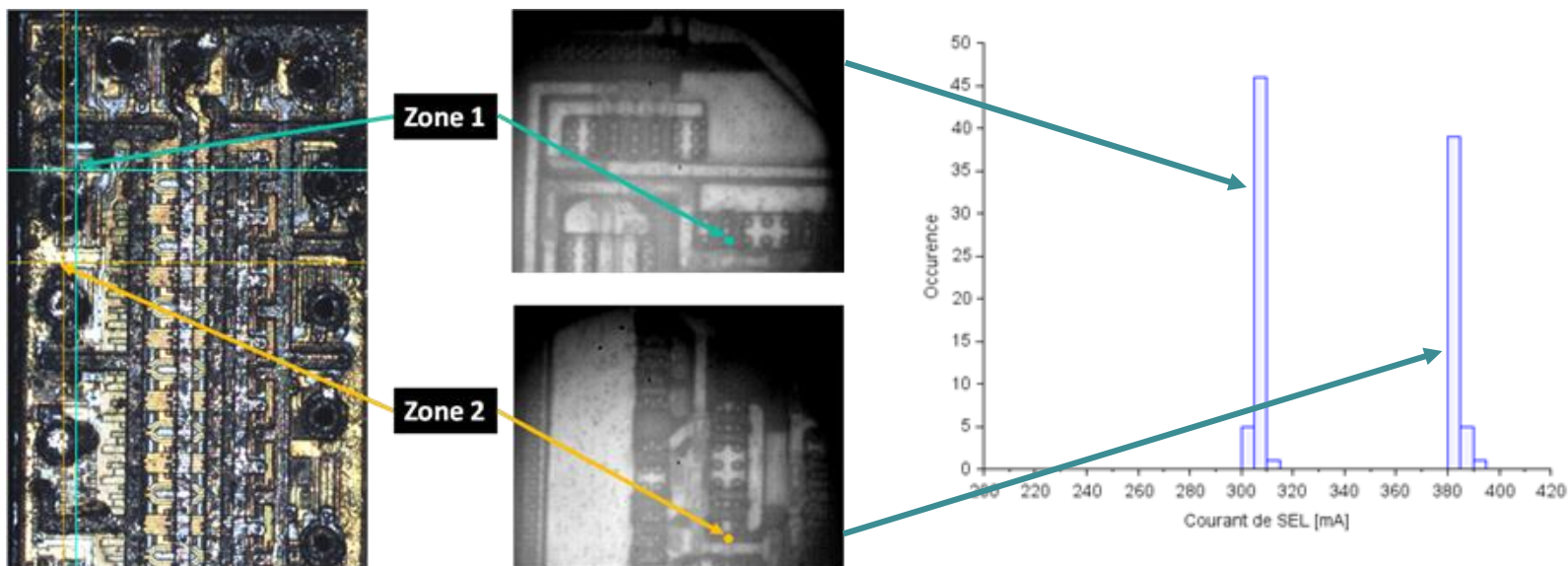
→ Very localized



■ Test procedure : 100 SEL (50 per sensitive zone) over 5 devices

■ Laser tests

- 74HC259D : SEL current histograms
- 100 SEL
 - 50 in Zone 1
 - 50 in Zone 2



Laser test

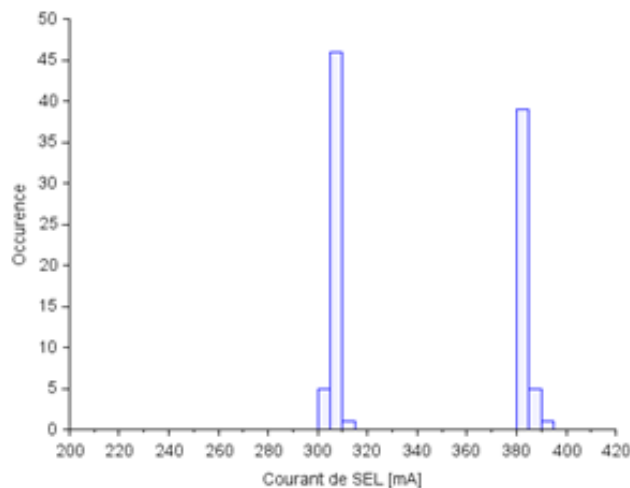
Pulse energy = 2.1 nJ
VCC = 5V
T = 125°C

SEL detection parameters

Threshold current = 30 mA
Hold time = 1 ms

■ Comparison with Heavy Ions test results

► 74HC259D : SEL current histograms



Laser test

Pulse energy = 2.1nJ

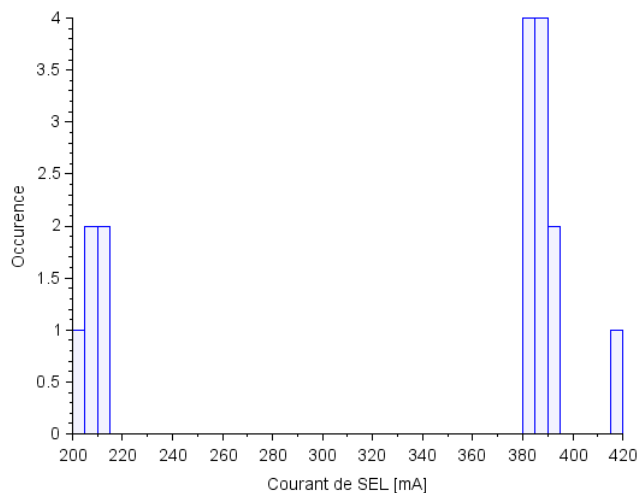
$V_{CC} = 5V$

$T = 125^{\circ}C$

SEL detection parameters

Threshold current = 30mA

Hold time = 1ms



Heavy ions

LET = 46.1 MeV.cm².mg⁻¹

$V_{CC} = 5V$

$T = 125^{\circ}C$

SEL detection

Threshold current = 10mA

Hold time = 1ms

Observations

- Same distribution with two distinct groups of SEL currents
- SEL current values slightly different
→ attributed to HI / laser test conditions

■ Life test on 74HC259D

- Performed at TRAD Montpellier
- Devices 3 to 9
 - 2 reference device

Devices
used
for
Life Test

Device number	Comments
1	Use for validation
2	Delidded + 100 SEL + LifeTest
3	Delidded + 100 SEL + LifeTest
4	Delidded + 100 SEL + LifeTest
5	Delidded + 100 SEL + LifeTest
7	Delidded + 100 SEL + LifeTest
8	Delidded + LifeTest
9	LifeTest (reference)

- Life test parameters

- Life test test board and conditions

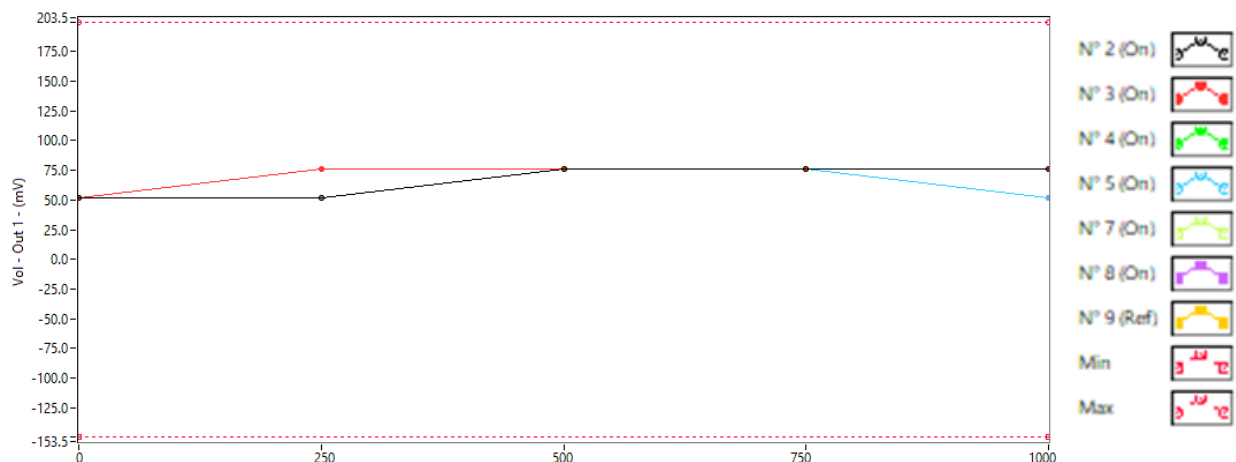
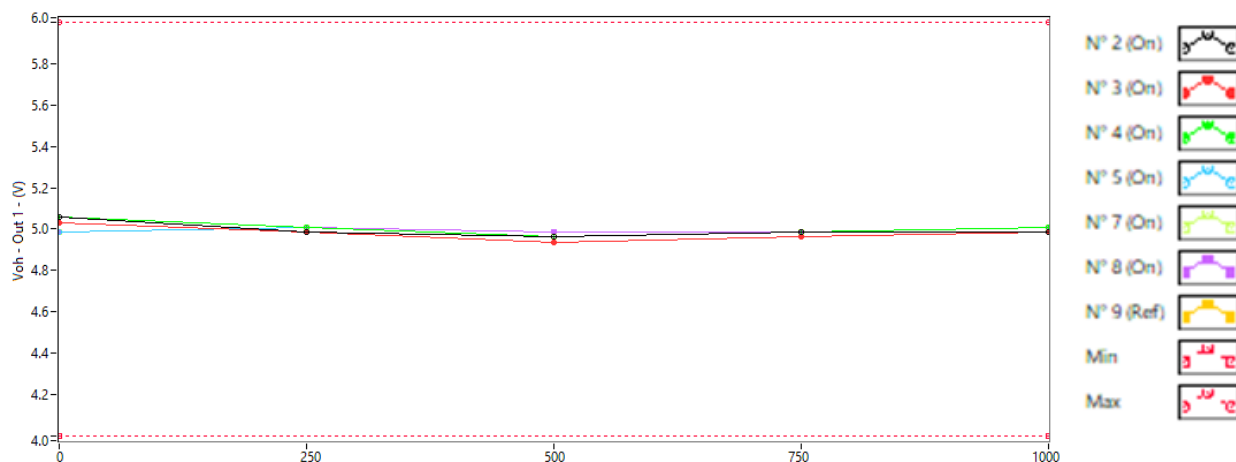
- Placed in the oven
- Opening each 250h



Duration	Temperature	Continuously measured parameter	Parameters measured every 250h
1000h	125°C	Consumption current I_{CC}	Q_0 : V_{OH} , V_{OL} , clock frequency Q_7 : (low level signal)

Evolution of studied electrical parameters

- Low level V_{OL} and high level V_{OH} of Q_1 (CLK)

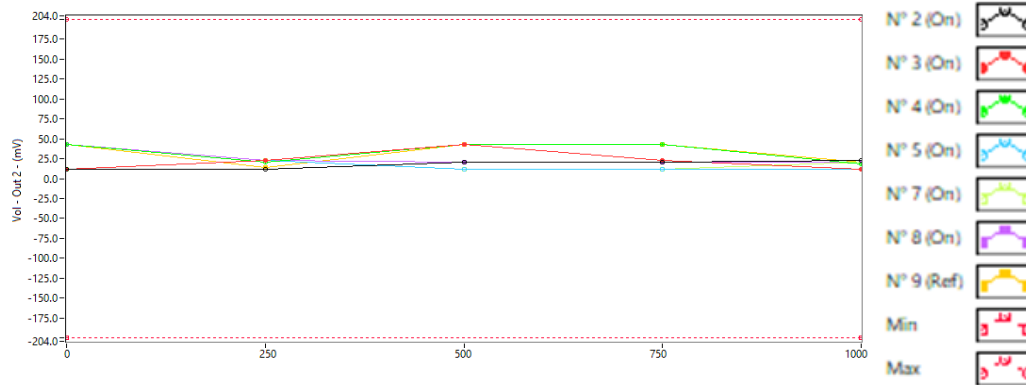


small variations due to measurement-induced noise

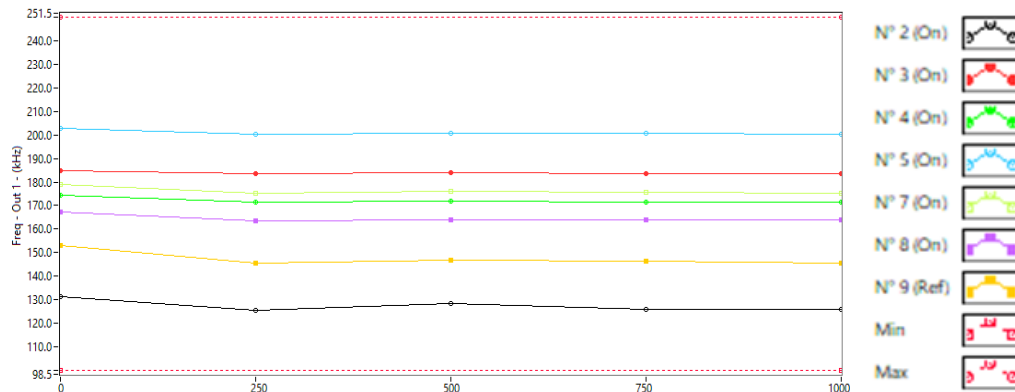
Life Test results

Evolution of studied electrical parameters

- Q₇ output (low level)



- Output frequency



- Current consumption I_{CC} : no impact

Observations

- Small variations due to measurement-induced noise
- No measurable impact of SEL
 - on studied parameters
 - in these conditions
 - Stressed 50 times the same area

→ Can help validating the implementability in a design with a latchup protection system

■ Conclusion of this preliminary study

- ✦ **Laser = reliable facility to reproduce the effects of heavy ions to trigger SEL**
- ✦ **Strategy → validated the feasibility of a test approach**
 - Use laser to localize sensitive area(s)
 - Trigger a controlled number of SEL in each sensitive area (50 times)
 - The Life Test is performed on :
 - Many irradiated devices to get a strong enough reliability
 - One delidded un-irradiated device to measure the impact of delidding
 - One undelidded unirradiated device used as a reference)
- **cost-efficient strategy to observe if a SEL induces a degradation on the studied component**
 - Before implementing a delatching system in the design
 - But need to validate the method by comparison with heavy ion testing

■ Upcoming study in 2021

- ✦ **Tests on many devices from**
 - Different technologies / complexities / functionalities
 - Various technological nodes
- **Have a broader sampling to validate the approach / more complete study on reliability**
- ✦ **Refine the laser test parameters**
 - Bibliography to get physical device parameters (structure, doping levels...)
 - Analytical estimation of laser energy to reproduce the LET used during heavy ion tests